

MOU Signing Ceremony between NIT and KICET

The memorandum of understanding (MOU) between Nagoya Institute of Technology (NIT) and Korea Institute of Ceramic Engineering Technology (KICET) has been signed on the 31st of March, 2008, at Ceramics Research Laboratory (CRL), NIT in Tajimi, Japan, by Prof. N. Ishizawa, the director of CRL, and Dr. K-J. Kim, the director of Ceramics Bank, KICET. The MOU includes cooperation on the distribution and application of ceramics materials data between two institutions, interlink between the web pages of NIT and KICET, development of collaborative training program for industry engineers through mutual visits, and collaborative research between NIT and KICET. They also exchanged small gifts for commemoration after the signing ceremony. The signers, Ishizawa and Kim, who are the same age and graduated from the same school in Japan many years ago, also congratulated themselves on their unexpected reunion after a long interval over separate countries. *Good to see you again.*



March 31, 2008 ni